



Patent  
Attorney's Docket No. 1003510-000161

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of	)	<b>MAIL STOP Issue Fee</b>
	)	
Tsutomu Saimoto et al.	)	Group Art Unit: 2811
	)	
Application No.: 10/506,806	)	Examiner: Shouxiang Hu
	)	
Filed: September 7, 2004	)	Confirmation No.: 5415
	)	
For: PRESSURE SENSITIVE ADHESIVE FILM	)	
FOR PROTECTION OF	)	
SEMICONDUCTOR WAFER SURFACE	)	
AND METHOD OF PROTECTING	)	
SEMICONDUCTOR WAFER WITH THE	)	
PRESSURE SENSITIVE ADHESIVE FILM	)	

**COMMENTS ON NOTICE OF ALLOWANCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

As part of the Notice of Allowance, certain Examiner's amendments were made to claim 3. Such changes to claim 3 were authorized with the understanding that the changes did not affect the substantive scope of the claim and the instant comments are being submitted for the purpose of confirming this understanding.

Respectfully submitted,

BUCHANAN INGERSOLL & ROONEY PC

By: Robert G. Mukai  
Robert G. Mukai  
Registration No. 28,531

P.O. Box 1404  
Alexandria, Virginia 22313-1404  
(703) 836-6620

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